

Resource Summary Report

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University of Michigan Lurie Nanofabrication Core Facility

RRID:SCR_026764

Type: Tool

Proper Citation

University of Michigan Lurie Nanofabrication Core Facility (RRID:SCR_026764)

Resource Information

URL: <https://Inf.engin.umich.edu/>

Proper Citation: University of Michigan Lurie Nanofabrication Core Facility (RRID:SCR_026764)

Description: Lurie Nanofabrication Facility serves technology educators and creators through broad access to advanced nanofabrication equipment and staff expertise in safe, collaborative environment. Equipment and processes are available for research on silicon integrated circuits, MEMS, III-V compound devices, organic devices and nanoimprint technology. We also encourage researchers from non-traditional disciplines to make use of our processes, such as metal and dielectric coatings, vacuum processes, fabrication of micro and nano components and metrology tools.

Synonyms: , Lurie Nanofabrication Facility, University of Michigan Lurie Nanofabrication Facility

Resource Type: core facility, service resource, access service resource

Keywords: ABRF, nanofabrication equipment, staff expertise, silicon integrated circuits, MEMS, III-V compound devices, organic devices, nanoimprint technology, metal and dielectric coatings, vacuum processes, fabrication of micro and nano components, metrology tools,

Availability: Open

Resource Name: University of Michigan Lurie Nanofabrication Core Facility

Resource ID: SCR_026764

Alternate IDs: https://coremarketplace.org/RRID:SCR_026764/?citation=1

Alternate URLs: ABRF_3158

Record Creation Time: 20250412T054911+0000

Record Last Update: 20260731T043225+0000

Ratings and Alerts

No rating or validation information has been found for University of Michigan Lurie Nanofabrication Core Facility.

No alerts have been found for University of Michigan Lurie Nanofabrication Core Facility.

Data and Source Information

Source: [SciCrunch Registry](#)

Usage and Citation Metrics

We have not found any literature mentions for this resource.